


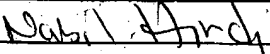
<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b>  <b>IN AN APPLICATION</b>  (Use several sheets if necessary)	Docket Number: 10873.0435USD2	Application Number: filed here within 10/10/848
	Applicant: SAIMI et al.	
	Filing Date: filed here within	Group Art Unit: n/a 2435

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
10/11	5,120,128	June 1992	Ulich et al.	—	—		
	5,126,996	June 1992	Iida et al.	—	—		
	5,416,757	May 1995	Luecke et al.	—	—		
	5,793,735	Aug. 1998	Oono	—	—		
	5,815,293	May 1995	Komma et al.	—	—		
	5,818,643	Oct. 1998	Fujioka	—	—		
	5,838,651	Aug. 1996	Takahashi	—	—		
	5,946,137	Feb. 1996	Momoo et al.	—	—		
	6,111,842	Jan. 1998	Nishino et al.	—	—		
	6,327,231	June 1997	Sano et al.	—	—		
	6,069,860	Nov. 1997	MIZUNO et al.	—	—		
	6,185,176	May 1998	SUGIURA et al.	—	—		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
10/11	10-289470	Oct. 1998	Japan	—	—		
	2001-507463	June 2001	Japan	—	—		
	517,491	Dec. 1992	EPO	—	—		
	5-282705	Oct. 1993	Japan	—	—		
	545,713	June 1993	EPO	—	—		
	720,159	July 1996	EPO	—	—		
	762,403	Sept. 1996	EPO	—	—		
	765,015 A1	March 1997	EPO	—	—		
	807,928	May 1996	EPO	—	—		
	844,606	May 1998	EPO	—	—		
99/18466	April 1999	WIPO	—	—			

EXAMINER	Nabel Hndy	DATE CONSIDERED	9/23/04
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.			

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b>  <b>IN AN APPLICATION</b>  (Use several sheets if necessary)	Docket Number: 10873.0435USD2	Application Number: filed here within 10/6/848
	Applicant: SAIMI et al.	
	Filing Date: filed here within	Group Art Unit: n/a 265

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
	01/1997	Numerical-Aperture Two-Element Objective Lens for the Optical Disk, YAMAMOTO et al., Jpn. J. Appl. Phys. Vol. 36 (1997) pp. 456-459

EXAMINER 	DATE CONSIDERED 9/23/04
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